

L Number	Hits	Search Text	DB	Time stamp
1	2219	(photoresist\$ or resist\$1) same (microlens\$2 or lenslet\$1 or lens\$2 or (focussing near5 screen))	EPO; JPO; DERWENT; IBM_TDB	2003/09/25 14:39
2	29545	(photoresist\$ or resist\$1) same (hole\$1 or depression\$1 or concave or concavities\$1 or crater\$1 or hollow or hole\$1 or well\$1 or opening\$1 or bowl)	EPO; JPO; DERWENT; IBM_TDB	2003/09/25 14:41
3	336	((photoresist\$ or resist\$1) same (microlens\$2 or lenslet\$1 or lens\$2 or (focussing near5 screen))) and ((photoresist\$ or resist\$1) same (hole\$1 or depression\$1 or concave or concavities\$1 or crater\$1 or hollow or hole\$1 or well\$1 or opening\$1 or bowl))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/09/25 14:41

<u>Set Name</u> side by side	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u> result set
<i>DB=USPT,PGPB,JPAB,EPAB,DWPI,TDBD; PLUR=YES; OP=OR</i>			
<u>L25</u>	L24 and I12	25	<u>L25</u>
<u>L24</u>	L23 and (I2 or I3)	62	<u>L24</u>
<u>L23</u>	(concave or concavities) with I1	843	<u>L23</u>
<u>L22</u>	L21 with (I2 or I3)	25	<u>L22</u>
<u>L21</u>	(concave or concavities or inverse or negative) with I1	1203	<u>L21</u>
<u>L20</u>	jp-62161532-\$.did. or jp-62161533-\$.did.	4	<u>L20</u>
<u>L19</u>	L18 or I17	33	<u>L19</u>
<u>L18</u>	L16 and I3	23	<u>L18</u>
<u>L17</u>	L16 and I2	23	<u>L17</u>
<u>L16</u>	L14 same I12	213	<u>L16</u>
<u>L15</u>	L14 and I12	335	<u>L15</u>
<u>L14</u>	(concave or concavities or inverse or negative) same (mold\$4 or stamp\$4 or emboss\$4 or master\$4)	41237	<u>L14</u>
<u>L13</u>	(concave or concavities) same (mold\$4 or stamp\$4 or emboss\$4 or master\$4)	19270	<u>L13</u>
<u>L12</u>	L1 same (mold\$4 or stamp\$4 or emboss\$4 or master\$4)	1703	<u>L12</u>
<u>L11</u>	L10 and I1	153	<u>L11</u>
<u>L10</u>	L3 and I2	6864	<u>L10</u>
<u>L9</u>	L8 not I7	4	<u>L9</u>
<u>L8</u>	L6 and I4	7	<u>L8</u>
<u>L7</u>	L6 and I5	5	<u>L7</u>
<u>L6</u>	L3 same I2	4076	<u>L6</u>
<u>L5</u>	((fill or fillfactor) with 100 or 99 or 98 or 97 or 96 or 95 or 94 or 93) same I1	758	<u>L5</u>
<u>L4</u>	(fill or fillfactor) same I1	516	<u>L4</u>
<u>L3</u>	(resist\$1 or photoresist\$1) with (laser\$1 or beam\$1)	27808	<u>L3</u>
<u>L2</u>	(resist\$1 or photoresist\$1) with (positive or az)	26976	<u>L2</u>
<u>L1</u>	(microlens\$6 or ((micro or array) near2 lens\$3) or lenslet\$1)	27365	<u>L1</u>

END OF SEARCH HISTORY